

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type::	Regular
Subject Matter::	Utility
Title::	HIGH FLUX X-RAY SOURCE
Attorney Docket Number::	Q79161
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	1
Total Drawing Sheets::	4
Small Entity?::	Yes

APPLICANT INFORMATION

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Poland
Status::	Full Capacity
Given Name::	Damian
Family Name::	KUCHARCZYK
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Country of Residence::	Poland
Street of mailing address::	ul. Stawowa 3/2
City of mailing address::	Wroclaw
Country of mailing address::	Poland
Postal or Zip Code of mailing address::	PL-5-018

CORRESPONDENCE INFORMATION

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REPRESENTATIVE INFORMATION

Representative Customer Number::	23493
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FOREIGN PRIORITY INFORMATION

Country::	Application number::	Filing Date::	Priority Claimed::
GB	0306829.3	3/25/200	Yes

ASSIGNEE INFORMATION

Assignee name::	OXFORD DIFFRACTION LTD.
Street of mailing address::	20 Nuffield Way
	Abingdon
City of mailing address::	Oxfordshire
Country of mailing address::	United Kingdom
Postal or Zip Code of mailing address::	OX14 1RL